



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Rico Cheng

Application No.: 10/045,781 (CONF-3009)

Filed: 1/12/2002

Title: Dual wafer-loss sensor and water-resistant
sensor holder

Attorney Docket No.: 67,200-604

Group Art Unit:
3723

Examiner:
Eziamara Anthony Ojini

Commissioner for Patents
Alexandria, VA 22313-1450

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: Feb. 11, 2004

[Handwritten signature of Kathy Dixon]
Kathy Dixon

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RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action of November 14, 2003, please amend the application as follows and consider the following remarks.